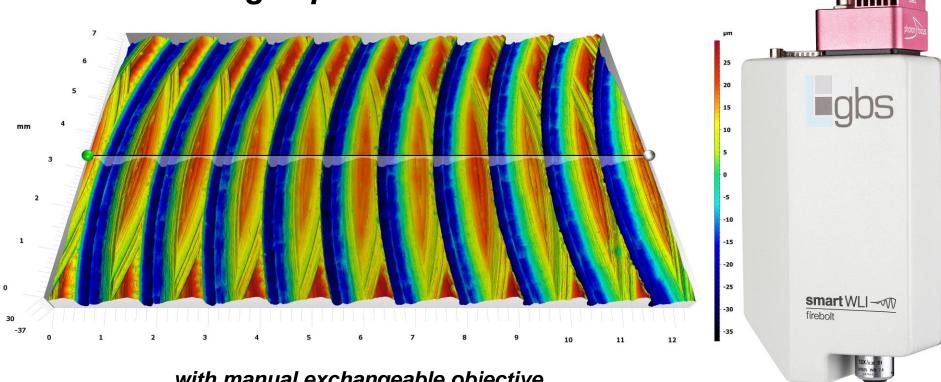
smartWLI firebolt







with manual exchangeable objective

advantages and applications



high speed sensor

with 10GigE Camera and 935 fps combined with real time calculation of 3d data

large area measurements

Fast single scans accelerate the high

resolution measurement of larger areas.

scanning of objects up to several cm2

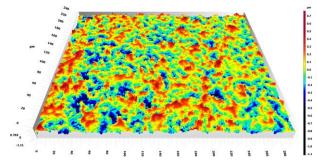
control of small defects

roughness measurements and large area

inline application

The speed of the data acquisition shortens the cycle times and reduces the impact of vibration.

- · inline roughness measurements
- · measuring of micro geometries
- without anti-vibration systems



24 23 38 34 36 30 31 30 4 4 4 2

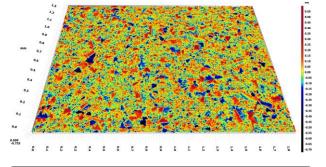
laser structured surface

plane glass

high resolution measurements

The speedy acquirement of many images out of the interference zone to reduce the sensor noise.

- wafer roughness
- control of optical surfaces
- measurement of super polished surfaces



super polished crystal mirror

general specification



sensor	measurement technique	white-light interferometry
33.133.	weight	ca. 2.1 kg
	height x width x depth	ca. 270 x 127 x 66 mm ³
camora	resolution	1280 x 1024
camera	interface	10 GigE
	speed full resolution	935 fps
scanning device	type	piezo positioning system
Scarning device	scan range	400 μm
	linearity	< 0.06%
control unit	PC	Core I9, 64 GB RAM, Windows 10, 1 TB SSD, GPGPU
	hardware components	piezo – controller
		light – controller
		controller for motorized stages (optional)
		100 - 240 VAC, 50/60 Hz
	housing	19" industrial rack
	weight	ca. 26 kg
	height x width x depth	ca. 300 x 520 x 400 mm³
software	surface scanning	smartVIS3D
Software	data evaluation	MountainsMap®
	3d calculation	real time on the GPGPU (general purpose graphic processing unit)
	height digitalization	dynamical, down too 0.01 pm
	image aquisition	infinite focus image without interference fringes
	data quality	accordance to an ideal interference signal for each measuring point
environment conditions	operation temperature	10 - 35 °C
	relative humidity	up to 80%; non-condensing

performance and objective specification



speed / full camera resolution	16 μm/s	65 μm/s	195 μm/s
repeatability RMS	0.004 nm	0.005	0.008
topography reproducibility	0.05 nm	0.1 nm	0.2 nm
1-σ repeatability 245 nm step	0.2 nm	0.2 nm	0.2 nm
1-σ repeatability 20 μm step	10 nm	3 nm	2 nm
1-σ repeatability 100 μm step	20 nm	10 nm	5 nm

	2.5x	5x	10x	20x	50x	100x	115x*
working distance / mm	10.3	9.3	7.4	4.7	3.4	2	0.7
aperture	0.075	0.13	0.3	0.4	0.55	0.7	0.8
measuring field / mm²	6.7 x 5.4	3.4 x 2.7	1.6 x 1.4	0.83 x 0.68	0.34 x 0.27	0.16 x 0.14	0.15 x 0.12
spatial sampling / µm	5.2	2.6	1.3	0.65	0.26	0.13	0.11

*repeatability RMS, 10x objective, EPSI, single scan, without profile averaging, lab conditions, 1 Million measuring points after 3x3 denoising filter

^{**}Sq/ $\sqrt{2}$ – profile difference of 2 scans, EPSI, single scan, without profile averaging, laboratory conditions, 1 million points after 3x3 denoising filter

^{***}Olympus 100x objective -calculated magnification in relation to the 100x Nikon objective

system configuration



XY(Z) stages and possible system configuration					
positioning area	movement	load capacity	resolution	orthogonality	encoder
73 x 55 mm²	manual	1 kg	-	-	•
100 x 100 mm²	motorized	2 kg	0.01 μm	<10arcsec	optional
200 x 200 mm²	motorized	3 kg	0.01 μm	<10arcsec	optional
300 x 300 mm²	motorized	5 kg	0.01 μm	<5arcsec	optional









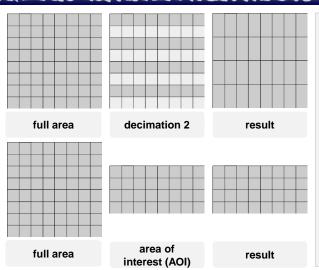


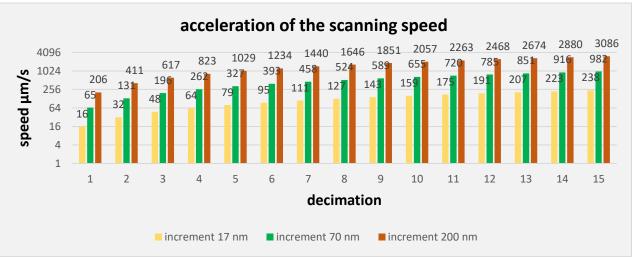


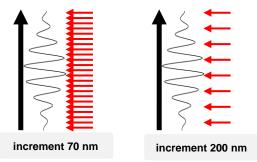
- standard stands with manual height and tilt adjustment and various stage configurations for lab measuring systems
- · portal measuring systems with extended height measuring range and motorized tip tilt
- · customized configuration of special measuring systems

high speed measurements





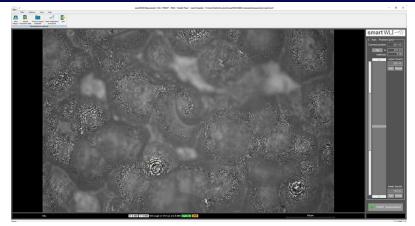


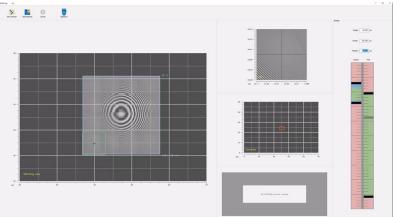


- the scanning speed is limited by the 10 GigE camera interface
- the reduction of the image seize by decimation or AOI's increase the scanning speed
- alternatively is it possible to increase the speed with bigger increments and a lower image density in the interference zone
- the accelerated scanning speed minimize the impact of environmental influence factors
- the accelerated scanning speed cause a higher system noise and limit the maximal possible scanning speed based on the requirements of the application

smartVIS3D - surface scanning







user interface	simplified and intuitive handlingconfiguration of scanning and measuring processes
scanning and measurement process control	objective selection control of scanning range and scanning process parameters scanning methods: overtical scanning interferometry extended phase shift interferometry profile averaging high density image aquisition selection of application specific scanning and evaluation macros optional control of motorized xyz-stages for automated scanning and evaluation of larger objects acceleration of scanning processes: sub-sampling decimation AOIs (reduced area of interest) flexible increments for z-scanning fast prescan for object and range detection image correction and contrast enhancement
calibration	lateral objective calibration flatness calibration

schemes and options for integration



smartVIS3D

MountainsMap

USB - IO Channels – triggering of measurements from the production line, return of pass/fail classifications with optional storage of results via Ethernet

SDK

control program

integration of the sensor into a customer-specific control program on the sensor's PC and control of handling systems or manufacturing processes via the sensor

SDK

integration of the sensor into a customer-specific control program of the production line and control of the measurements and evaluation processes via the production line (client-server architecture)

production line

control program

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